

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/525,202 Confirmation No. 7662
Applicant: Kazuo ONISHI, ET AL.
Filed: April 14, 2006
TC/A.U.: 1795
Examiner: Raymond Alejandro

Title: ELECTRODE FORMING METHOD

Docket No. : 3103.111

FIRST INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicant encloses an Information Disclosure Statement Citation Form (PTO 1449) which lists the reference cited in the attached European Search Report Action dated January 24, 2008.

Applicant certifies under 37 C.F.R. 1.97(e)(1) that the document submitted herewith was cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of this Statement. Therefore, it is respectfully urged that no fees are required for the Examiner's consideration of the document listed in this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

The Commissioner is authorized to charge any necessary fees or credit fees to Deposit Account No. 50-4080.

Respectfully Submitted,

/Stephen Parker Reg. No. 36631/

By: _____
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